

04/12/01
jc839 U.S. PTO

04-16-01

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Docket No. 005651/ETCH/CHMBR/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): Michael BARNES and David Palagashvili
Title: PLASMA REACTOR ELECTRODE

jc921 U.S. PTO
09/834343
04/12/01

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 9 pages.
- ☒ Drawings totaling 2 pages, ☒ Formal ☐ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☒ Assignment of the invention to **Applied Materials, Inc.**
- ☒ Assignment Recordation Cover Sheet
- ☒ Information Disclosure Statement (37 CFR 1.98)

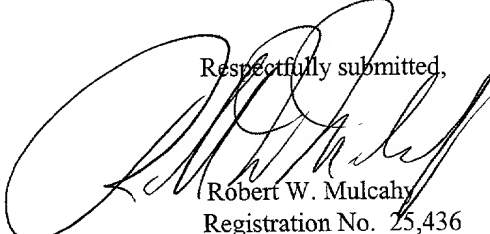
| FEE CALCULATION | | | | | |
|--------------------|--------------|-------------------------|--------------|----------|----------|
| Fee Items | Claims Filed | Included With Basic Fee | Extra Claims | Fee Rate | Total |
| Total Claims | 16 | -20= | 0 | X\$18.00 | \$000.00 |
| Independent Claims | 2 | -3= | 0 | X\$80.00 | \$000.00 |
| Basic Filing Fee | | | | \$710.00 | \$710.00 |
| TOTAL FEES | | | | | \$710.00 |

- ☒ The Commissioner is hereby authorized to charge \$710.00 to Deposit Account No. 50-1074.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:
**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D C 20231

Express Mail Receipt No EL66180502545
Date of Deposit 4-12-2001
Signature Beit Mulcahy

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436